

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

		Application Number	10789809
		Filing Date	2004-02-27
		First Named Inventor	Trevor W. Freeman
		Art Unit	2439
		Examiner Name	Benjamin A Kaplan
		Attorney Docket Number	MS1-1747US

U.S.PATENTS

Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear
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	1	Heinl, et al., "A Comprehensive Approach to Flexibility in Workflow Management Systems", WACC 1999, ACM, 1999, pp 79-88	<input type="checkbox"/>

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